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Project Aim	Expected Results
Build a sensing system for movement measurement use electronic potential sensors.	Detect spatial potential, electric field. Monitoring electric field disturbance. Record the data for further analysis. All these cause by large dielectric object move through the local electric field, the dielectric objects will interference the electric field.
EPIC sensor	Procedure
The electronic potential sensor or the EPIC sensor. Ultra High Impedance Movement	Step 1 Research review And Test Pre-work existing technology Step 2 Step 3 Step 4 Step 4 Step 4 Step 3 Step 4 Present a report Verification Modification
	use EPIC sensor
PIESSEY	Contact BingQian YAN
	EPIC sensor The electronic potential sensor or the EPIC sensor. Ultra High Impedance Movement Sensor Produce by Plessey Semiconductors

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